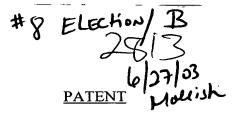


Attorney Docket No. 5649-919



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Jeong-hee Chung et al.

Group Art Unit: 2813

Serial No.: 10/047,706

Examiner: Tuan H. Nguyen Confirmation No.: 3888

Filed: January 15, 2002 For:

SEMICONDUCTOR CAPACITORS HAVING TANTALUM OXIDE

LAYERS AND METHODS FOR MANUFACTURING THE SAME

June 20, 2003

Mail Stop Non-Fee Amendment Commissioner for Patents Box 1450 Alexandria, VA 22313-1450

**AMENDMENT** 

Sir:

This Amendment is responsive to the Official Action of June 12, 2003. Applicants are filing the present Amendment pursuant to the Revised Amendment Format instituted by the prototype Electronic File Wrapper program described in 1265 Off. Gaz. Pat. Office 87 (December 17, 2002) and that has been expanded to include all Technology Centers and amendments to the specification and drawings. Thus, the provisions of 37 C.F.R. 1.121(a), (b), (c) and (d) are waived for the present Amendment.

In re: Jeong-her chung et al. Serial No.: 10/047,706

Filed: January 15, 2002

Page 2 of 5

## In the Title:

Please delete the title in all occurrences and substitute the following title therefor:

--SEMICONDUCTOR CAPACITORS HAVING TANTALUM OXIDE LAYERS--.